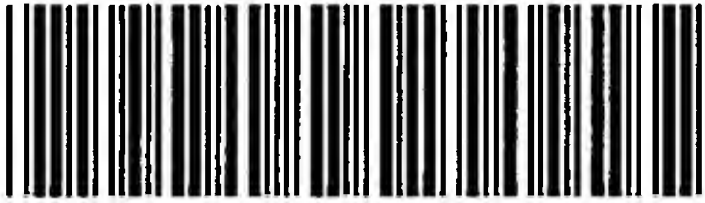


Search Notes

Application/Control No.

10/604,820

Examiner

Jeffrey Donels

Applicant(s)/Patent under
Reexamination

CHI, CHAO-WEN

Art Unit

2837

SEARCHED

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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

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